

Notice of References Cited

Application/Control No.

09/838,384

Applicant(s)/Patent Under
Reexamination
CHA ET AL.

Examiner

Mike Qi

Art Unit

2871

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,292,239	09-2001	Nagamura et al	349/58
	B	US-5,815,227	09-1998	Lee	349/67
	C	US-5,818,555	10-1998	Yokoyama et al	349/67
	D	US-6,309,081	10-2001	Furihata	362/31
	E	US-6,175,396	01-2001	Kim et al	349/58
	F	US-6,016,175	01-2000	Kim	349/58
	G	US-5,659,376	08-1997	Uehara et al	349/58
	H	US-5,654,779	08-1997	Nakayama et al	349/58
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11-133401	11-1999	Japan	Susumu et al	G02F 1/1335
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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